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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/887,697	11/01/2001	Shih-Fu Lee	146712013800	3474

7590

10/05/2005

Raj S. Dave
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2000 Pennsylvania Avenue
Washington, DC 20006

EXAMINER

PROCTOR, JASON SCOTT

ART UNIT

PAPER NUMBER

2123

DATE MAILED: 10/05/2005

Please find below and/or attached an Office communication concerning this application or proceeding.



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APPLICATION NO./ CONTROL NO.	FILING DATE	FIRST NAMED INVENTOR / PATENT IN REEXAMINATION	ATTORNEY DOCKET NO.
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EXAMINER

ART UNIT	PAPER
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20050930

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Commissioner for Patents

NOTICE OF NON-RESPONSIVE AMENDMENT

The reply filed on 30 June 2005 is not fully responsive to the prior Office Action because of the following omission(s) or matter(s): Response to 37 CFR 1.105 Requirement for Information. See 37 CFR 1.111. Since the above-mentioned reply appears to be bona fide, applicant is given ONE (1) MONTH or THIRTY (30) DAYS from the mailing date of this notice, whichever is longer, within which to supply the omission or correction in order to avoid abandonment. EXTENSIONS OF THIS TIME PERIOD MAY BE GRANTED UNDER 37 CFR 1.136(a).

Mr. Raj Dave (42,465) has indicated via telephonic interview on 28 September 2005 that the Requirement for Information was received with the previous Office Action. For Applicants' convenience, the list of required material is reiterated below.

"Effects of Disc-Microwaviness in an Ultra-High Density Magnetic Recording System" presented by Wei Yao, David Kuo, and Jing Gui at ASME Tribology Conference 1999 in Orlando, Florida


Paul L. Rodriguez

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RS